



April 1, 2002  
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Form PTO-1449 U.S. Department of Commerce  
Patent and Trademark Office

Atty. Docket No. Serial No.

17310-239350 10/040,282

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

Applicant

CATHERINE A. MORLEY

Filing Date  
October 19, 2001

Group 1765

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
SA	2,854,336	9/30/58	Gutknecht	216	47	
	3,647,584	3/7/72	Duffy	216	47	
	3,931,641	1/6/76	Watrous	360	109	
	4,167,765	9/11/79	Watrous	360	103	
	4,235,664	11/25/80	Menke	216	41	
	4,251,318	2/17/81	Oberg et al	216	41	
	4,391,683	7/5/83	Buckley et al	209	129.3	
	4,415,262	11/15/83	Koyama et al	355	125	
	4,578,318	3/25/86	Schoch et al	428	615	
	5,157,003	10/20/92	Tsuji et al	437	229	
	5,275,695	1/4/94	Chang et al	216	47	
	5,313,355	5/17/94	Hagen	360	104	
	5,428,490	6/27/95	Hagen	360	104	
	5,438,212	8/1/95	Okaniwa	257	275	
✓	5,770,513	6/23/98	Okaniwa	438	587	
SA	5,846,442	12/8/98	Pasco	216	41	

FOREIGN PATENT DOCUMENTS

Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SA	The Theory and Application of a Simple Etch Contour for Near Ideal Breakdown Voltage in Plane and Planar p-n Junctions; Temple, Victor A.K.; Adler, Michael S.; Vol. ED-23, No. 8, August 1976.
SA	Quantitative Examination of Photofabricated Profiles Parts 1-6: Design of Experiments; Allen, D.M.; Horne, D.F.; Stevens, G.W.W.; The Journal of Photographic Science, Vol. 25, 1977.

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M2:20451799.01

Shun Amd

5/12/03